



Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. XENOP007/PXE-035 Applicant: Nelson, et al. Filing Date February 6, 2002	Application No.: 10/068,573 Group 2872 2614
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
<i>Wm</i>	A1	5,650,135	7/22/1997	Contag et al.	424	9.1	7/1/94
	A2						
	A3						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
<i>Wm</i>	B1	WO 00/17643	3/30/00	WIPO	G01N	33/53	X	
	B2							
	B3							
	B4							
	B5							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
<i>Wm</i>	C1	Integrated Photomatrix Limited, "Closed Loop Control", Dorset, England available 12/01/01
	C2	Dynex Technologies, Inc., website, A Thermo BioAnalysis Company "Dynex Microplates", http://www.dynextechnologies.com/index.html , printed 4/19/02
	C3	Optronic Laboratories, Inc., website, Manufacturer of Light Measurement Instrumentation, Standards, http://olinet.com/ , printed 4/19/02
	C4	Labsphere, website http://labsphere.com , printed 4/19/02
	C5	Lambda Research Corporation, website, http://lambdaresearch.com , printed 4/19/02
	C6	Hamamatsu Corporation, USA, website, http://usa.hamamatusu.com/ pages 1-4, 04/27/2001, printed on 4/27/2001.
<i>Wm</i>	C7	Hamamatsu, Imaging Box Instruction Manual, 55310-224-1, November 2000.
Examiner <i>Wm K. J. F.</i>		Date Considered <i>9-8-04</i>

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.